

ENERGY GRADIENT ION BEAM DEPOSITION OF CARBON OVERCOATS ON RIGID DISK MEDIA FOR MAGNETIC RECORDINGS

The fabrication of an overcoat layer starts with a low energy ion beam to avoid magnetic

layer implantation problems, followed by higher deposition energies where the higher energy 5 atoms are implanted into the previously formed lower energy overcoat layer, rather than the magnetic layer. The energy gradient ion beam deposition process therefore results in a thin overcoat layer that is denser than a comparable layer formed by low energy magnetron sputtering, and which overcoat layer provides good mechanical and corrosion protection to the magnetic layer.

10